# IAP13 Rec'd PCT/PTO 19 SEP 2006

## SEP 19 2006 W IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

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Yoichi KOBAYASHI et al

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Serial No. 10/568,085

Mail Stop: PCT BRANCH

Filed: July 26, 2006

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Title: Polished state monitoring apparatus and polishing apparatus using the same

#### REQUEST FOR CORRECTED FILING RECEIPT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Enclosed herewith is a copy of the Official Filing Receipt for the above-identified application marked in red indicating corrections to be made thereto. Also, make corrections indicated in on the Notice of Acceptance.

Accordingly, it is requested that the PTO issue a Corrected Filing Receipt reflecting these corrections.

Respectfully submitted,

Yoichi KOBAYASHI et al

By

Nils E. Pedersen

Registration No. 33,145 Attorney for Applicants

/eak

WENDEROTH, LIND & PONACK, L.L.P. 2033 K. St., N.W., Suite 800 Washington, D.C. 20006-1021 Telephone (202)721-8200 September 19, 2006



## United States Patent and Trademark Office

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademy Address: COMMISSIONER FOR PATENT: P.O. Box 1450 Alexandria, Vinjinia 22313-1450 www.uspto.gov

U.S. APPLICATION NUMBER NO.

FIRST NAMED APPLICANT

ATTY. DOCKET NO. 2.006-0139 A -20060139A

10/568,085

Yoichi Kobayashi

INTERNATIONAL APPLICATION NO.

PCT/JP04/08787

I.A. FILING DATE

PRIORITY DATE

06/16/2004

09/10/2003

000513 WENDEROTH, LIND & PONACK, L.L.P. 2033 K STREET N. W. SUITE 800 **WASHINGTON, DC 20006-1021** 

Wenderoth, Lind & Ponack L.L.P.

**CONFIRMATION NO. 7770** 371 ACCEPTANCE LETTER \*OC000000020208657\*

Date Mailed: 08/29/2006

#### NOTICE OF ACCEPTANCE OF APPLICATION UNDER 35 U.S.C 371 AND 37 CFR 1.495

The applicant is hereby advised that the United States Patent and Trademark Office in its capacity as a Designated / Elected Office (37 CFR 1.495), has determined that the above identified international application has met the requirements of 35 U.S.C. 371, and is ACCEPTED for national patentability examination in the United States Patent and Trademark Office.

The United States Application Number assigned to the application is shown above and the relevant dates are:

07/26/2006

07/26/2006

DATE OF RECEIPT OF 35 U.S.C. 371(c)(1), (c)(2) and (c)(4) REQUIREMENTS

DATE OF COMPLETION OF ALL 35 U.S.C. 371 REQUIREMENTS

A Filing Receipt (PTO-103X) will be issued for the present application in due course. THE DATE APPEARING ON THE FILING RECEIPT AS THE "FILING DATE" IS THE DATE ON WHICH THE LAST OF THE 35 U.S.C. 371 (c)(1), (c)(2) and (c)(4) REQUIREMENTS HAS BEEN RECEIVED IN THE OFFICE. THIS DATE IS SHOWN ABOVE. The filing date of the above identified application is the international filing date of the international application (Article 11(3) and 35 U.S.C. 363). Once the Filing Receipt has been received, send all correspondence to the Group Art Unit designated thereon.

The following items have been received:

- Copy of the International Application filed on 02/13/2006
- Copy of the International Search Report filed on 02/13/2006
- Preliminary Amendments filed on 02/13/2006
- Information Disclosure Statements filed on 02/13/2006
- Oath or Declaration filed on 07/26/2006
- Reguest for Immediate Examination filed on 02/13/2006
- U.S. Basic National Fees filed on 02/13/2006
- Assignment filed on 07/26/2006
- Priority Documents filed on 02/13/2006
- Specification filed on 02/13/2006
- Claims filed on 02/13/2006



## United States Patent and Trademark Office

1030

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. States Alexandria, Virginia 22313-1450

APPL NO.

FILING OR 371 (c) DATE

ART UNIT FIL FEE REC'D

DRAWINGS TOT CLMS

**CONFIRMATION NO. 7770** 

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IND CLMS

07/26/2006 10/568.085

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WASHINGTON, DC 20006-1021

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FILING RECEIPT OC000000020208656\*

Date Mailed: 08/29/2006

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE. NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

#### Applicant(s)

Yoichi Kobayashi, Tokyo, JAPAN; Ryuichiro Mitani, Tokyo, JAPAN;

Power of Attorney: The patent practitioners associated with Customer Number 000513.

### Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP04/08787 06/16/2004

#### Foreign Applications

JAPAN 2003-318307 09/10/2003

If Required, Foreign Filing License Granted: 08/27/2006

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US10/568,085** 

**Projected Publication Date: 12/07/2006** 

Non-Publication Request: No

Early Publication Request: No

Title

OVE TO

POLISHED STATE MONITORING APPARATUS AND POLISHING APPARATUS USING THE SAME

Method and apparatus for measuring a polishing condition

Preliminary Class

073

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